

**Notice of References Cited**

Application/Control No.

10/069,603

Applicant(s)/Patent Under  
Reexamination  
KOBAYASHI ET AL.

Examiner

Hai Vo

Art Unit

1794

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**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-6,589,664	07-2003	Kobayashi et al.	428/516
	B	US-			
	C	US-			
	D	US-			
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
*	N	EP 1095764 A2	05-2001	European Patent	KOBAYASHI et al.	
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	S					
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**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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